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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2895  
Examiner: Swapneel CHHAYA

In Re PATENT APPLICATION of:

Applicant(s):	Takamitsu YAMANAKA	)
U.S. Serial No.:	10/577,457	)
U.S. Filing Date:	April 27, 2006	)
International Serial No.:	PCT/JP2005/014208	)
International Filing Date:	August 3, 2005	)
Priority Date Claimed:	August 17, 2004	)
For:	SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD	)
Attorney Reference:	AI 409NP	)

**AMENDMENT**

September 24, 2009

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on June 24, 2009, please  
amend the above-identified application as follows: